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	Filing Date		2006-08-22	
	First Named Inventor	VINK		
	Art Unit			
	Examiner Name			
Attorney Docket Number		NL040217		

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/AS/	3	TORSI ET AL: "MULTI-PARAMETER GAS SENSORS BASED ON ORGANIC THIN-FILM-TRANSISTORS"; SENSORS AND ACTUATORS B, VOL. 67, NO. 3, SEPTEMBER 1, 2000, PP. 312-316; ELSEVIER SEQUOIA S.A., LAUSANNE, CH.; XP004229038.	<input type="checkbox"/>
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/AS/	5	SZABO ET AL: "STRATEGIES FOR TOTAL NOx MEASUREMENT WITH MINIMAL CO INTERFERENCE UTILIZING A MICROPOROUS ZEOLITIC CATALYTIC FILTER", SENSORS AND ACTUATORS B: VOLUME 88, ISSUE 2, JANUARY 15, 2003, PP. 168-177.	<input type="checkbox"/>
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/AS/	7	KONG ET AL: "NANOTUBE MOLECULAR WIRES AS CHEMICAL SENSORS"; SCIENCE 287, 622 (2000); DOI: 10.1126/SCIENCE.287.5453.622.	<input type="checkbox"/>
/AS/	8	CUI ET AL: "NANOWIRE NANOSENSORS FOR HIGHLY SENSITIVE AND SELECTIVE DETECTION OF BIOLOGICAL AND CHEMICAL SPECIES"; SCIENCE 293, 1290 (2001), DOI: 10.1126/SCIENCE.1062711.	<input type="checkbox"/>
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